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M1W 11)4199 Equivalent to Form HTO-1595

	ne Hon. Commissioner of Patents and Trademarks se record the attached original or copy there if	Attach bar code label here:
	Docket No. JG-SU-4886	
1-	Name of Conveying Party(ies): Kazus	shige TAKAISH and Ryoko TAKADA
2-	- · · · · · · · · · · · · · · · · · · ·	bishi Materials Silicon Corporation and bishi Materials Corporation
		htemachi 1-chome, Chiyoda-ku, o, JAPAN respectively
3-	Nature of Conveyance: [X] Assignment [] Change of Name [] Merger [] Security Agreement [] Other:	Application number(s) or Patent number(s): If this document is being filed together with a new application, the execution date of the application is: A) Application number(s): 09/384,143
	EXECUTION DATE: August 10, 1999	B) Patent number(s):
5-	Name and Address of party to whom correspondence concerning document should be mailed: Jules E. Goldberg, Esq. McAulay Nissen Goldberg Kiel & Hand, LLP 261 Madison Avenue New York, NY 10016-2391 (212)986-4090	6- Total number of applications and patents involved: one
		7- TOTAL FEE (37 CFR 3.41): \$ 40.00 [X] Enclosed (The Commissioner is hereby authorize charge the deposit account any additional fees required or credit any overpayment to Deposit Account No: 13-0025.) [] Authorized to be charged to Deposit Account No: 13-0025.)
	(212)000-4000	8- Deposit Account No: 13-0025
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9-	Statement and Signature To the best of my kr attached copy is a tr	nowledge and belief, the foregoing information is true and correct and any rue copy of the original document.
	Jules E. Goldberg Reg. No.: 24,408 Name of Person Signing Signature	November 1, 1999 Date
	Total number of page	es including cover sheet, attachments, and documents:
I here	TIFICATE OF MAILING by certify that this correspondence is being deposite envelope addressed to: Assistant Commissioner for	ed with the United States Postal Service as first class ma r Patents, Washington, DC 20231 on <u>November 1, 199</u>

PATENT REEL: 010358 FRAME: 0005

ASSIGNMENT - PATENT APPLICATION UNITED STATES OF AMERICA

Whereas, I/We (1) Kazushige TAKAISHI and Ryoko TAKADA
of (2) <u>c/o Silicon Research Center, Mitsubishi Materials Corporation,</u>
1-297 KITABUKURO-CHO, OMIYA, SAITAMA, JAPAN (hereinafter "Assignor")
have invented certain new and useful improvements in
(3) CLEANING METHOD OF SEMICONDUCTOR SUBSTRATE
for which application for Letters Patent in the United States of America (4) x is about to be filed. has been filed. MITSUBISHI MATERIALS SILICON CORPORATION And Whereas, (5) MITSUBISHI MATERIALS CORPORATION
of (6) 5-1, Ohtemachi 1-chome, Chiyoda-ku, Tokyo, Japan (hereinafter "Assignee")
is/are desirous of acquiring an interest therein and in the Letters Patent to be obtained therefor:
Now, therefore, be it known by all whom it may concern, that for good and valuable consideration
(the sufficiency of which is hereby acknowledged) the Assignor has assigned, transferred and set over, and by these
presents does assign, transfer and set over unto the said Assignee for the territory of the United States of America, the
full and exclusive right, title, and interest in and to the said invention, as fully set forth and described in the
specification.
A. prepared and executed on (8) even date herewith
(7) B. filed in the U.S. Patent and Trademark Office under Serial No. (9) on (10)
including any division, continuation, substitute or renewal application thereof; said invention, application and Letters
Patent to be held and enjoyed by the said Assignee to the full end of the term for which said Letters Patent is granted,
as fully and entirely as the same would have been held by the Assignor had this assignment and transfer not been
made.
Assignor hereby authorizes and requests the Commissioner of Patents and Trademarks to issue any
and all such Letters Patent for said invention to said Assignee.
In testimony whereof, the Assignor has hereunto set his hand this
(11) day of August 19 99
WITNESS: INVENTOR(S): (1) Kasushige Takaishi Kazushige TAKAISH (2) Rytho Tokada Ryoko TAKADA (3)
MCAULAY NISSEN GOLDBERG KIEL & HAND, LLP 261 MADISON AVENUE, NEW YORK, N.Y. 10016-2391